



This technology is currently not available for licensing

Tech ID: 21824

ADDITIONAL TECHNOLOGIES BY THESE INVENTORS

- ▶ [Vertical Cavity Surface-Emitting Lasers with Continuous Wave Operation](#)
- ▶ [Enhanced Light Extraction LED with a Tunnel Junction Contact Wafer Bonded to a Conductive Oxide](#)
- ▶ [Methods to Produce and Recycle Substates for III-Nitride Materials with Electrochemical Etching](#)
- ▶ [III-Nitride Tunnel Junction with Modified Interface](#)
- ▶ [III-Nitride Tunnel Junction LED with High Wall Plug Efficiency](#)
- ▶ [Novel Multilayer Structure for High-Efficiency UV and Far-UV Light-Emitting Devices](#)
- ▶ [A Method To Lift-Off Nitride Materials With Electrochemical Etch](#)
- ▶ [Nitride Based Ultraviolet LED with an Ultraviolet Transparent Contact](#)

